

<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	Atty Docket No.	Application No.:
	GENSP014	10/726,802
	Applicant:	
	Kobayashi	
	Filing Date	Group
	December 2, 2003	2181

#### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
/CKL/	A1.	2004/0049705	03-11-04	Liebenow			09-05-02
	A2.						
	A3.						
	A4.						
	A5.						

#### Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation Yes	No
	B1.							
	B2.							
	B3.							
	B4.							
	B5.							

#### Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1.	
	C2.	
	C3.	
	C4.	

Examiner	/Chun-Kuan Lee/	Date Considered	03/21/2007
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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### Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
/CKL/	C1.	Examination Report dated November 13, 2006 from related European Patent Application No. 04255609.2.
	C2.	
	C3.	
	C4.	

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